

<b>Notice of References Cited</b>	Application/Control No. 09/656,709	Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Kim-Kwok CHU	Art Unit 2653	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,370,090	04-2002	Verbakel et al.	369/30.04
	B	US-6,205,112	03-2001	Weidner	369/275.3
	C	US-6,031,808	02-2000	Ueno	369/111
	D	US-5,835,589	11-1998	Nakashima	369/275.2
	E	US-5,812,519	09-1998	Kawamura et al.	369/275.2
	F	US-5,864,785	11-1997	Itami et al.	369/275.2
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.